

A beam shaping active optics system for FERMI@Elettra FEL



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FERMI@Elettra









FEL-1, based on a single stage High Gain Harmonic Generation (HGHG) scheme initialized by a UV laser, covers the spectral range from ~100 nm down to 20nm



FEL-2, is based on a double cascade of HGHG in order to be able to reach the wavelength range from 20 nm to \sim 4 nm



FERMI@Elettra output







Experimental hall









TIMEX: ultrafast **TI**me-resolved studies of **M**atter under **EX**treme and metastable conditions

Main scientific goals:

- ultrafast studies (conductance, reflectivity, trasmission, scattering) of warm dense matter (WDM)

- transitions occurring in stable, metastable and excited states under extreme conditions







Beamline design





Expected a spot size $\sim 3 \ \mu m$

Up to 10¹⁷ W/cm²







The natural spatial Gaussian distribution of the focused photon beam is not suitable for the TIMEX porpuses



Need for a versatile beam-shaping system

In the VUV/soft X-ray range the beam-shaping is possible by using reflective elements with peculiar shapes



Use a bendable-plane mirror as an active optics























Almost **Flat-top** spot for irradiating the sample uniformly







Flat-top spot with tales for irradiating the sample and probing the temperature with a pyrometer







Ray tracing Vs wavefront propagation









The sides of the mirror are clamped and the shape is changed due to the effect of the applied forces below the substrate



13 Piezo-actuators glued on the bottom of the mirror's substrate



The active mirror



Substrate 400 mm x 40 mm x 10 mm

> Optical area 360 mm x 20 mm



Residual slope errors (after best sphere subtraction): Tang. < 0.5 μ rad rms, Sag. < 5 μ rad rms (within 70 mm length)

Micro roughness < 0.3 nm rms

Coating: Gold 50 nm



Straing-gauges and piezo









Straing-gauges and piezo









IWXM, Barcelona, July 5th 2012



Straing-gauges and piezo







Metrology results











Metrology results LTP











Central part (300 mm) $P_t V = 4.5 \mu m$





The Adaptive Correction Tool (ACT) calculates

- the iteraction matrix for a bimorph mirror with N piezos

-the voltage to apply to the piezo-actuators in order to obtain the desired mirror profile

Adaptive Correction Tool

Calculate N	ew CORRECTION vector
	Input error file
Choose File	no file selected
	Calculatel

Calculate	New	INTERACTION MATRIX
Nu	umber o	f Pulse files
	(Up)	sad Pulse files)

[Close][Howto pdf]

Adaptive Correction Tool

Adaptive Correction Tool

Pulse Files Upload

Remember to upload PULSE files in the right sequence

1st: no pulse on any electrode; 2nd: pulse on first electrode; 3rd: pulse on first & second electrode; ...; (N+1)th: pulse on ALL n electrodes of the mirror

Shape [0000]	Choose File no file selected
Shape [10.00]	(Choose File) no file selected
Shape [11.00]	Choose File no file selected
	Choose File no file selected
Shape [1110]	Choose File no file selected
Shape [1111]	Choose File) no file selected
	Pulse Voltage (Volt):
	(Calc Matrix)
	[Back] [Close]





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CH.	Voltage Correction	
00	-12.4 V	
01	-13.7 V	
02	-2.6 V	
03	-10.1 V	
04	+4.6 V	
05	-4,7 V	
06	+16.6 V	
07	+1.1 V	
08	-9.1 V	
09	-8.2 V	
10	-9.8 V	
11	-8.3 V	
12	-7.0 V	









Metrology results LTP





 $P_t V \sim 34 \ \mu m \ !!!!!!!$



Metrology results LTP









Performed both ray tracing and wavefront propagation simulations Mirror + Staing-gauges and piezo actuators work fine

Design a brand new holder (suggestions are very welcome)

We will use the same scheme for the KB system for correcting the FEL wavefront deformations (L. Raimondi tomorrow morning)

TIMEX beamline will be operative in a temporary configuration for the first user dedicated beamtime





Thank you for your attention!

Colleagues and collaborators

F. Bencivenga, R. Borghes, G. Bortoletto, C. Callegari, M. Cautero,
F. Cianciosi, R. Cucini, D. Cocco, F. D'Amico, A. Di Cicco,
N. Mahne, C. Masciovecchio, E. Principi, L. Raimondi, R. Sergo,
D. Spiga, G. Sostero, M. Zangrando